

Notice of References Cited	Application/Control No. 10/698,821	Applicant(s)/Patent Under Reexamination SHIVELY ET AL.	
	Examiner Bena Miller	Art Unit 3725	Page 1 of 1

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*	C	US-D408,871	04-1999	Herlitz, Todd S.	D21/517
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*	E	US-D488,519	04-2004	Niu, Li-Yang	D21/516
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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